



AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP ART UNIT: 2812

PATENT APPLICATION  
Q-51885

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Akitaka KIMURA

Appln. No.: 09/161,981

Group Art Unit: 2812

Confirmation No.: 8269

Filed: September 29, 1998

Examiner: Mulpuri, S

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND  
METHOD FOR DEPOSITING SEMICONDUCTOR LAYER

**AMENDMENT UNDER 37 C.F.R. § 1.116,**  
**REQUEST FOR RECONSIDERATION,**  
**AND**  
**REQUEST FOR INTERVIEW**

**BOX AF**

Commissioner for Patents  
Washington, D.C. 20231

Sir:

In response to the "final" Office Action (Paper No. 18) mailed November 20, 2002,  
please amend the above-identified application as follows:

#20/a (NG)  
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Surles  
-5/2/3

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14325 201  
10 2000 1000 1000

AMENDMENT UNDER 37 C.F.R. § 1.116  
U.S. APPLN. NO. 09/161,981

**IN THE DRAWING**

See the enclosed Proposed Drawing Correction.